



Docket No.: 51876P377

TFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

SUNG-KWON LEE

Application No.: 10/648,172

Filed: August 25, 2003

For: **METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE USING ARF
PHOTOLITHOGRAPHY CAPABLE OF
PROTECTING TAPERED PROFILE OF HARD
MASK**

Art Group:

Examiner:

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

The above-captioned application, an amendment thereto, or an Appeal Brief was filed more than 18 months ago and no substantive Office Action has issued to date. Please provide the current status of the application and an indication of when the next Action is expected to issue.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: _____

5/3/05

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CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Nadya Gordon 5/4/05
Nadya Gordon
Date